

MIT Museum Invites you to Meet Ron Fierstein, Author of A Triumph of Genius: Edwin Land, Polaroid, and the Kodak Patent War

This non-fiction legal thriller captures the life of Polaroid founder Edwin Land and tells the story of the company's epic court battle with Eastman Kodak

On February 24th from 6:00pm – 7:30pm, the MIT Museum invites you to meet Ron Fierstein, author of A Triumph of Genius: Edwin Land, Polaroid, and the Kodak Patent War. This non-fiction legal thriller captures the life of Polaroid founder Edwin Land and tells the story of the company's epic court battle with Eastman Kodak. Ron Fierstein worked closely with Edwin Land as a young lawyer on the team of litigators representing Polaroid in court. A Triumph of Genius gives an unprecedented account of one of the most significant patent litigations of the 20th century. Following the discussion, Fierstein will sign copies of his new book. A Triumph of Genius will be available for purchase at the Museum store.

For more information go to <http://web.mit.edu/museum/visit/calendar.html>.

MIT Museum – Meet Ron Fierstein Author of A Triumph of Genius: Edwin Land,
Polaroid, and the Kodak Patent War
Tuesday, February 24
6:00 – 7:30pm
265 Massachusetts Avenue
Cambridge, MA
617-253-5927

For more information go to: <http://web.mit.edu/museum/visit/calendar.html>

General admission: \$10.00 for adults; Youth under 18, students, seniors:
\$5.00; free admission for MIT card holders and alumni.
Free Admission Check website for times and discounts
Parking: Metered street parking and area lots
Public Transportation: Red Line "T" to Central Square or #1 Bus